



PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, Washington, DC 20231.

December 31, 2001

Date

Rena Iov

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Present Application**

Applicants : Chee Peng Neo, Cher Khng Victor Tan, Kian Seng Ho and Hock Chuan Tan

Application No. : 09/944,247 Confirmation No.: 1800

Filed : August 30, 2001

For : METHOD AND APPARATUS FOR DETECTING TOPOGRAPHICAL FEATURES OF MICROELECTRONIC SUBSTRATES

Docket No. : 108298548US

Date : December 31, 2001

**Foreign Application**

Application No. : 200104881-8

Country : Singapore

Filed : August 13, 2001

Commissioner for Patents  
Washington, DC 20231

**PRELIMINARY AMENDMENT**

Dear Commissioner:

Please amend the application as follows and consider the application in light of the following remarks.